

HEWLETT-PACKARD COMPANY
Intellectual Property Administration
P. O. Box 272400
Fort Collins, Colorado 80527-2400

PATENT APPLICATION

ATTORNEY DOCKET NO. 10011959-5

IN THE
UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Chien-Hua Chen

Confirmation No.: 1367

Application No.: 10/666,609

Examiner: OEN, William L.

Filing Date: Sept. 18, 2003

Group Art Unit: 2855

Title: A Pressure Sensor and Method of Making the Same Having Membranes Forming a Capacitor

Mail Stop Amendment
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

TRANSMITTAL LETTER FOR RESPONSE/AMENDMENT

Sir:

Transmitted herewith is/are the following in the above-identified application:

- (X) Response/Amendment () Petition to extend time to respond
() New fee as calculated below () Supplemental Declaration
(X) No additional fee
() Other: _____ (fee \$ _____)

CLAIMS AS AMENDED BY OTHER THAN A SMALL ENTITY						
(1) FOR	(2) CLAIMS REMAINING AFTER AMENDMENT	(3) NUMBER EXTRA	(4) HIGHEST NUMBER PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	(6) RATE	(7) ADDITIONAL FEES
TOTAL CLAIMS	20	MINUS	62	= 0	X \$50	\$ 0
INDEP. CLAIMS	4	MINUS	13	= 0	X \$200	\$ 0
[] FIRST PRESENTATION OF A MULTIPLE DEPENDENT CLAIM					+ \$360	\$ 0
EXTENSION FEE	1ST MONTH \$120.00	2ND MONTH \$450.00	3RD MONTH \$1020.00	4TH MONTH \$1590.00		\$ 0
OTHER FEES						\$
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$ 0

Charge \$ 0 to Deposit Account 08-2025. At any time during the pendency of this application, please charge any fees required or credit any overpayment to Deposit Account 08-2025 pursuant to 37 CFR 1.25. Additionally please charge any fees to Deposit Account 08-2025 under 37 CFR 1.16 through 1.21 inclusive, and any other sections in Title 37 of the Code of Federal Regulations that may regulate fees. A duplicate copy of this sheet is enclosed.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450.

Respectfully submitted,

Chien-Hua Chen

By

Steven L. Nichols

Attorney/Agent for Applicant(s)

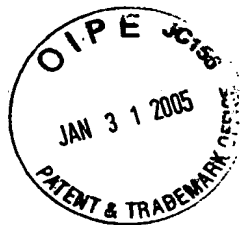
Reg. No. 40,326

Date of Deposit: Jan. 27, 2005

Typed Name: Rebecca R. Schow

Signature: 

Date: Jan. 27, 2005



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Continuation Application of
Chien-Hua Chen

Serial No.: 10/666,609

Filed September 18, 2003

For: A Pressure Sensor and Method of
Making the Same Having Membranes
Forming a Capacitor (as amended)

Group Art Unit: 2855

Examiner: OEN, William L.

RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the non-final Office Action of 2 November 2004, please consider the
following:

IN THE TITLE:

Please amend the title of the present application as follows:

A Pressure Sensor and Method of Making the Same Having Membranes
Forming a Capacitor